



**ELECTRONIC COPY**

LG758591007  
Report verification at igi.org



December 22, 2025

IGI Report Number **LG758591007**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **8.49 - 8.55 X 5.41 MM**

**GRADING RESULTS**

Carat Weight **2.47 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

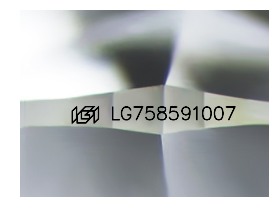
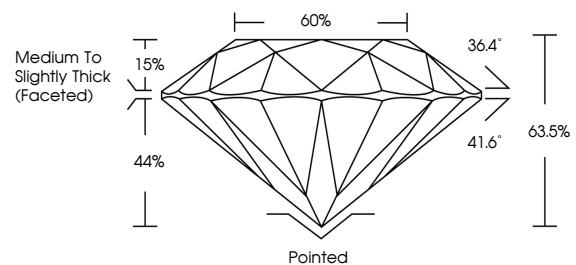
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG758591007**

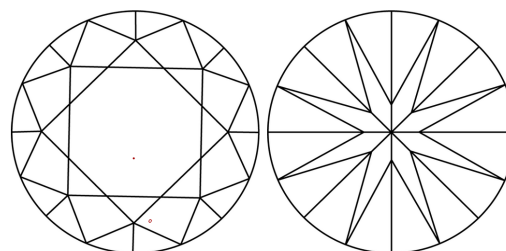
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

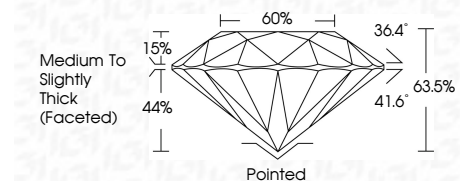
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

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**ROUND BRILLIANT**  
8.49 - 8.55 X 5.41 MM  
2.47 CARATS  
E  
VS 1  
EXCELLENT  
63.5%  
60%  
Medium To Slightly Thick (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG758591007

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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